



Serial No. 09/851,089

SEC.837

Amendment dated 16 January 2004

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re PATENT APPLICATION of:

Jong-Woon OH et al.

Group Art Unit: 1744

Serial No.: 09/851,089

Examiner: Laura C. COLLETT

Filed: 9 May 2001

CLEANING APPARATUS FOR  
SEMICONDUCTOR WAFER

RECEIVED  
JAN 22 2004  
TC 1700

**REQUEST TO WITHDRAW FINALITY OF OFFICE ACTION  
AND  
AMENDMENT UNDER 37 C.F.R. § 1.113 AND/OR 1.116**

U.S. Patent and Trademark Office  
2011 South Clark Place  
Customer Window, Mail Stop **AF**  
Crystal Plaza Two, Lobby, Room 1B03  
Arlington, VA 22202

Sir:

In response to the FINAL Office Action dated 24 October 2003, please amend the above-identified patent application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 5 of this paper.